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Fenwick & West LLP
Two Palo Alto Sq
Palo Alto, CA 94306

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In re Reissue Application of
Meisburger et al.
Reissue Application No. 09/502,534
Filed: February 10, 2000
Original Patent No. 5,717,204
Issue Date: February 10, 1998
For: INSPECTING OPTICAL MASKS WITH
ELECTRON BEAM MICROSCOPY

DECISION ACCORDING
STATUS

OFFICE OF PETITIONS
A/C PATENTS

This is a decision on the petition under 37 CFR 1.47(a) filed October 2, 2000.

The petition is granted.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This reissue application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(a), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the Declaration. Notice of the filing of this reissue application will also be published in the Official Gazette.

To expedite the examination in progress, this reissue file is being forwarded to Technology Center AU 2878. **It is noted that the declarations filed with the petition lack compliance with 35 USC 115 and 37 CFR 1.63(a)(3) as they lack the citizenship of every named inventor, e.g., Mr. Meisburger and Mr. Emge.** AS THIS IS A REQUIREMENT OF STATUTE NOT SUBJECT TO WAIVER, CORRECTED-SUPPLEMENTAL REISSUE DECLARATIONS SHOULD BE FILED PROMPTLY OR WHEN REQUIRED BY THE EXAMINER.

Telephone inquiries related to this decision should be directed to the undersigned at (703) 305-1820.

Brian Hearn

Brian Hearn
Petitions Examiner
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy

Enclosure: Corrected Filing Receipt